Docket No.: 60188-861 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Satoshi TAMURA, et al. : Confirmation Number:

Serial No.: : Group Art Unit:

Filed: May 21, 2004 : Examiner:

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICES

## INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the document listed on the attached form PTO-1449. It is respectfully requested that the document be expressly considered during the prosecution of this application, and that the document be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of Japanese Laid-Open Patent Publication No. 2001-274507, is discussed in the present specification.

## Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Date: May 21, 2004

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INFORMATION DISCLOSURE CITATION IN AN  " "APPLICATION  APPLICANT Satoshi TAMURA, et al.			
APPLICANT Satoshi TAMURA, et al.			
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(PTO-1449) FILING DATE May 21, 2004 GROUP			
U.S. PATENT DOCUMENTS			
EXAMINER'S   Document Number   Publication Date   Name of Patentee or Applicant of Cited   Pages, Columns, L	ines, Where		
INITIALS   CITE   Number-Kind Codes (6 known)   MM-DD-YYYY   Document   Relevant Passages	Relevant Passages or Relevant Figures Appear		
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FOREIGN PATENT DOCUMENTS	4434×4		
EXAMINER'S INITIALS CITE NO.  Foreign Patent Document Country Codes (if known)  Foreign Patent Document Country Codes (if known)  Fublication Date MM-DD-YYYY Applicant of Cited Document Codes (if known)  Figures Appear			
Yes	No		
JP 2001-274507 A 10/05/2001 PIONEER ELECTRONIC CORP. JAPAN (w/English Abstract)			
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)			
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.